

SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE DEVICE
SN. 10/720,738; Akio SUGI, et al.
15/74
Replacement Sheet

Fig. 16

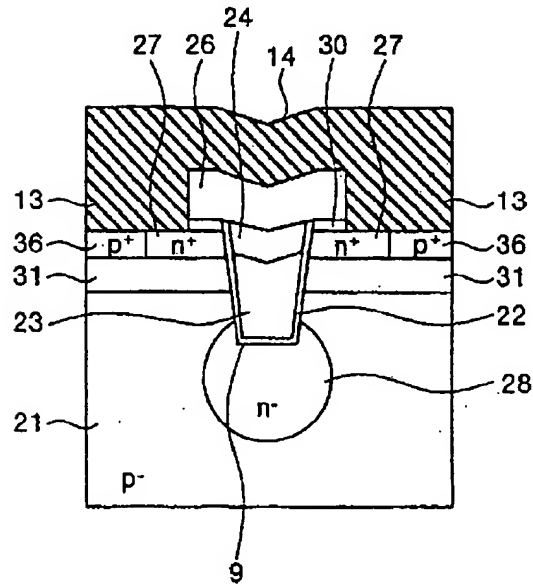
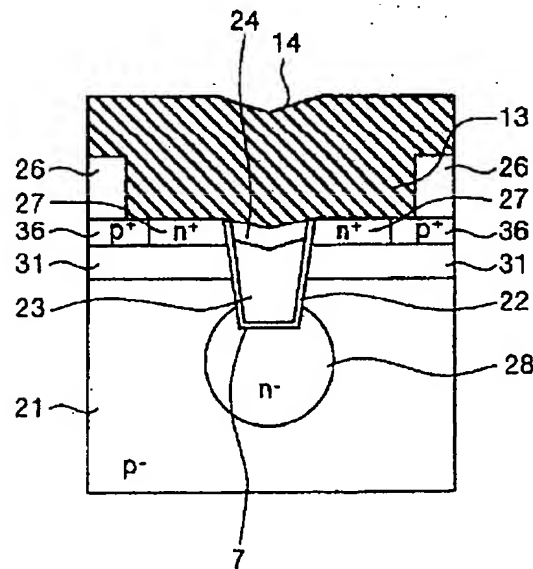


Fig. 17



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Fig. 19

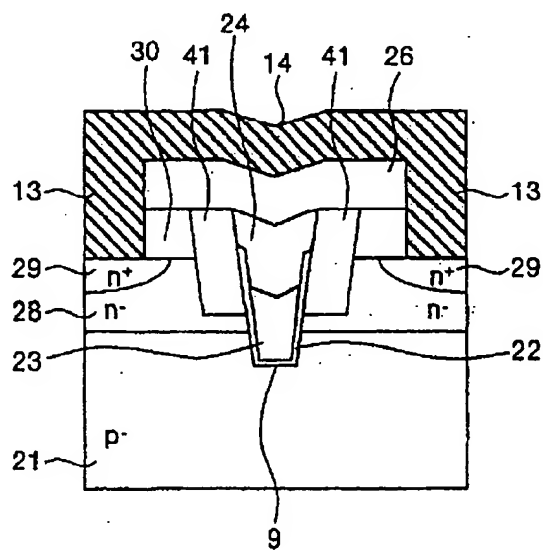
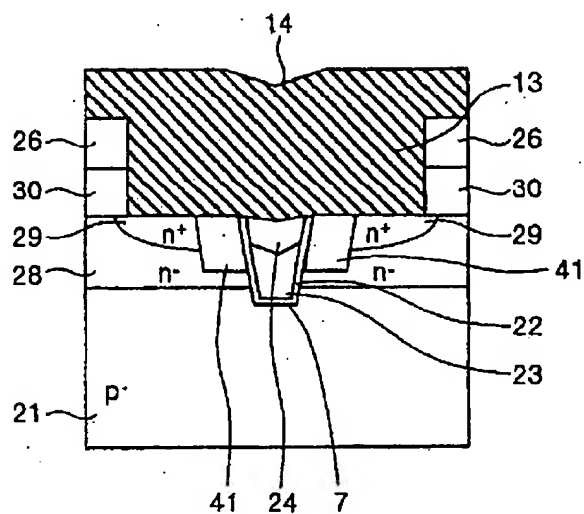


Fig. 20



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Fig. 25

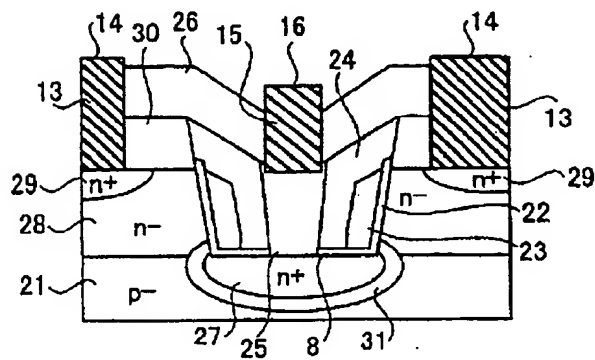
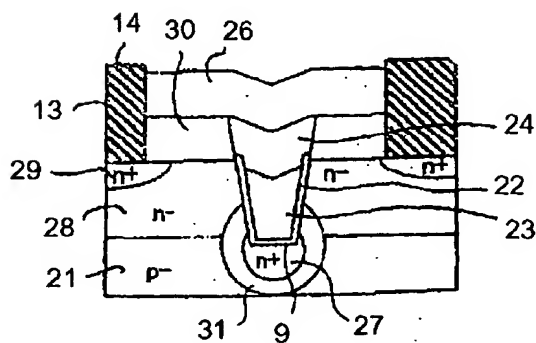


Fig. 26



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Fig. 55

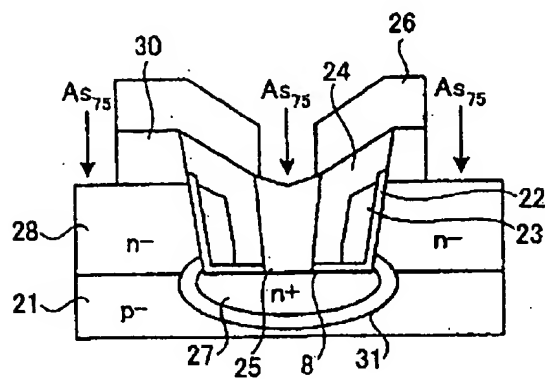


Fig. 56

